

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Attorney Docket No.: 47233-0044-00-US	Serial No.: 10/507,127
	Applicants Keiichi ABE et al.	Page 1 of 1
PTO Form 1449	Filing Date: September 10, 2004	Group Art Unit: 1794

U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	Translation	
					YES	NO

OTHER DOCUMENTS

(Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)

		ISHIKAWA et al., "Thin-Layer Chromatography – Basis and Applications," December 10, 1963, pp 9-11, Nanzando Co., Ltd., Japan (partial translation)

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